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<p>Substitute for form 1449A/PTO</p> <p><b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b></p> <p><i>(use as many sheets as necessary)</i></p>				<b>Complete if Known</b>	
				<b>Application Number</b>	09/908,727
				<b>Filing Date</b>	July 20, 2001
				<b>First Named Inventor</b>	Hisashi OHTANI et al.
				<b>Group Art Unit</b>	2812
				<b>Examiner Name</b>	R. Booth
<b>Sheet</b>	1	<b>of</b>	1	<b>Attorney Docket Number</b>	0756-2328

## U.S. PATENT DOCUMENTS

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Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		T <sup>2</sup>
<i>AB</i>		AYA et al., <i>Improvement of SPC Poly-Si Film Using the ELA Method</i> , AM-LCD '97 Digest of Technical Papers, September 11-12, 1997, Pages 167-170.		
<i>AB</i>		ABE et al., <i>High-Performance Poly-Crystalline Silicon TFT's Fabricated Using the SPC and ELA Methods</i> , AM-LCD '98 Digest of Technical Papers, July 9-10, 1998, Pages 85-88.		

Examiner Signature Huber, AC Date Considered 01/11/07 \*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance.